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AMENDMENT IN:

Applicants: Masahiko HATA et al.
Serial No.: 10/577,069

Confirmation: 4111
Art Unit: 2891

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PATENT
7372/88130

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Masahiko HATA et al.	Confirmation:	4111
Serial No.:	10/577,069	Art Unit:	2891
Filed:	June 20, 2006	Examiner:	J. Slutsker
For:	Method for manufacturing compound semiconductor substrate		

RULE 133 STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

December 23, 2008

Sir:

Applicants' legal representative acknowledges the courtesy extended by the Examiner during the brief telephone conference of December 17, 2008. The conversation centered on the Office Action June 25, 2008, in particular, page 4, paragraph 6, and the rejection based on Mori (JP 6-349731).

The rationale for the rejection described in paragraph 6 seems to be predicated on the Examiner's having had access to and considered a translation of the Mori '731 reference, a non-English language patent document. Applicants' legal representative now understands the Examiner either secured a translation or had a machine-generated translation made and relied on this translation in formulating the rejection based on the Mori '731 reference.

Applicants' legal representative noted that such a translation had not been provided as an attachment to or enclosure with the Office Action of June 25, 2008, and respectfully pointed out the difficulty in responding to the rejection when the Examiner was apparently relying on information not available to Applicants' legal representative.

Application Serial No. 10/577,069
Attorney Docket No. 7372/88130

It was suggested that under the circumstances, the translation be provided to Applicants' legal representative and the period for responding to the Office Action be reset.

Respectfully submitted,

FITCH, EVEN, TABIN & FLANNERY

BY:



Kendrew H. Colton, #30,368

Customer No. 65297
One Lafayette Centre
1120 - 20th Street, NW
Suite 750, South
Washington, DC 20036
(202) 419-7000 (telephone)
(202) 419-7007 (telecopier)
KHC:rk